

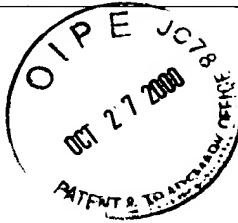
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Ext 1
Docket No.: M4065.0073/P073
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Donald L. Yates

Application No.: 09/123,430

Filed: July 28, 1998



Group Art Unit: 2823

Examiner: B. Kebede

For: METHOD OF REDUCING SURFACE
CONTAMINATION IN
SEMICONDUCTOR WET-PROCESSING
VESSELS

REQUEST FOR EXTENSION OF TIME

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

Applicant hereby petitions for a one month extension of time to and including November 5, 2000 to respond to the Office Action mailed July 5, 2000. Our check in the amount of \$110.00 covering the fee set forth in 37 CFR 1.17(a)(1) is enclosed.

In the event that a further petition for an extension of time is required to be submitted at this time, applicant hereby petitions under 37 CFR 1.136(a) for an extension of time for as many months as are required to ensure that the above-identified application does not become abandoned.

The Commissioner is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper

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hereafter filed in this application by this firm) to our Deposit Account No. 04-1073, under Order No. M4065.0073/P073. A duplicate copy of this paper is enclosed.

Dated: October 27, 2000

Respectfully submitted,

By  _____

Thomas J. D'Amico

Registration No.: 28,371

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